

Notice of References Cited	Application/Control No. 10/806,603	Applicant(s)/Patent Under Reexamination DAVIES ET AL.	
	Examiner John C. Hong	Art Unit 3726	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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FOREIGN PATENT DOCUMENTS

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	N	JP410275545	10-1998	Japan	Niwa et al.	—
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NON-PATENT DOCUMENTS

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